

Pulsed laser deposition of Zn(O,Se) layers for optoelectronic applications = Impulsslaser-sadestatud Zn(O,Se) kiled optoelektronseteks rakendusteks

Ibrahim, Akram Abdalla Mohammed 2021 <https://digikogu.taltech.ee/et/Item/0d07be7f-3737-4350-9de4-80f32df036de>
https://www.eester.ee/record=b5470705*est <https://doi.org/10.23658/taltech.57/2021>